

High-Efficient XFELO Based on Optical Resonator with Self-Modulated Q-Factor

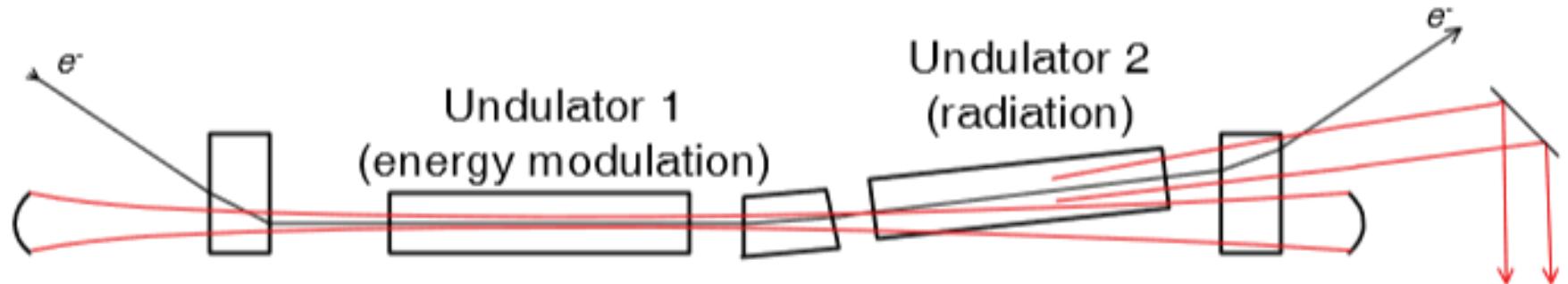
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MOTIVATION

Novosibirsk FEL Outcoupling Scheme*



Electron outcoupling scheme with two undulators and bending section between them.

Advantage --- XFELO easily starts.

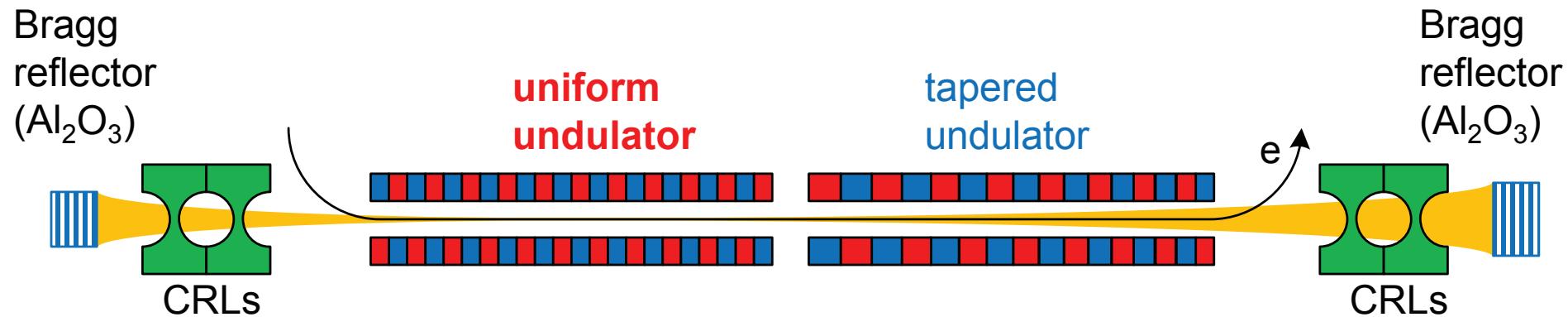
**Concerns --- bending magnet spoils e-beam;
X-rays accumulated in the resonator are lost;
high efficiency might be problematic;**

*A.N. Matveenko, O.A. Shevchenko, V.G. Tcheskidov, N.A. Vinokurov. ELECTRON OUTCOUPLING SCHEME FOR THE NOVOSIBIRSK FEL , Proceedings of FEL 2007, Novosibirsk, Russia, TUAAU02.

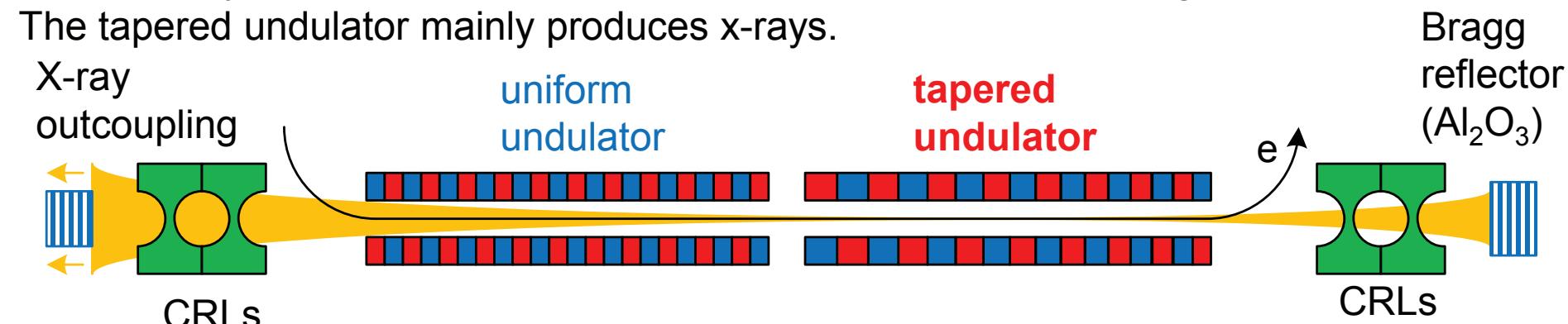
CONCEPT

XFELO Based on Optical Resonator with Self-Modulated Q-Factor

- At start condition Q-factor obtains maximum possible value due to proper optics. The uniform undulator leads the XFELO.



- At steady-state condition Q-factor is reduced due to outcoupling. The tapered undulator mainly produces x-rays.



Working Condition

The two-undulator concept works well only if power generated by a given bunch in the tapered undulator is much greater than power loss due to outcoupling (in this case X-ray field structure can be considered as fully controlled by the tapered undulator).

This conditions means that Pierce parameter must be as large as to satisfy:

$$\exp(L_{tu}/L_{gain}) \gg P_{out}$$

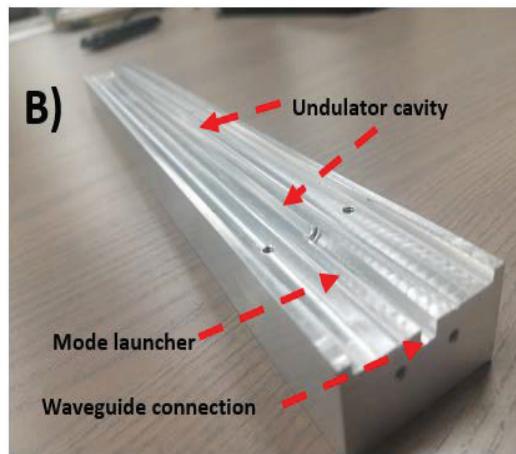
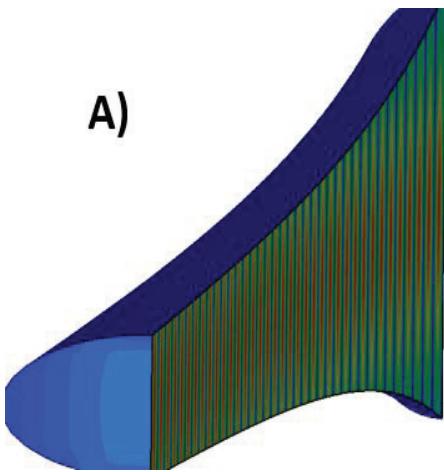
where P_{out} – normalized power loss per single wave passage in the resonator, L_{tu} – length of the tapered undulator, $L_{gain} = \lambda_u / 4\pi\rho$ - gain length, ρ - Pierce parameter, $\rho \propto (K_u I / \gamma_0^3)^{1/3}$

The above equations show that high-current bunches of small cross-section sizes are preferable.

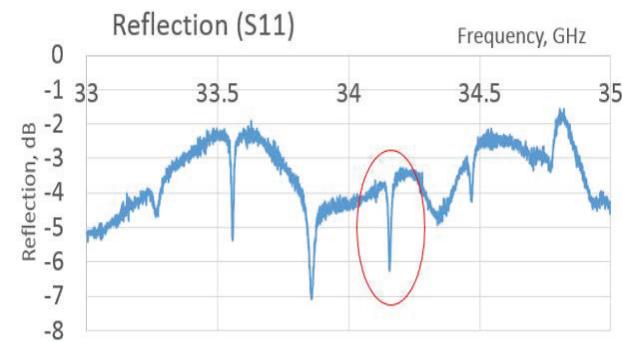
Such bunches are being produced by laser-plasma accelerators. Large energy spread can be mitigated by trapping regime in the tapered undulator.

RESEARCH @ EUCLID

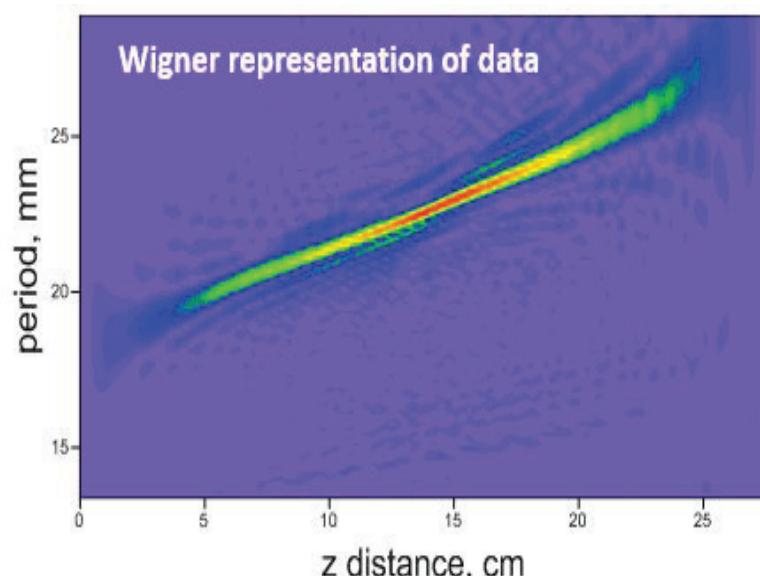
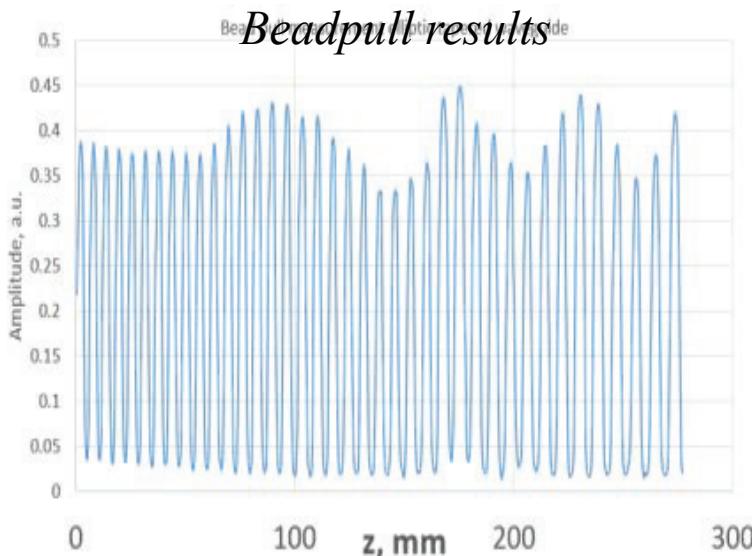
Strongly Tapered RF Undulators R&D at Euclid



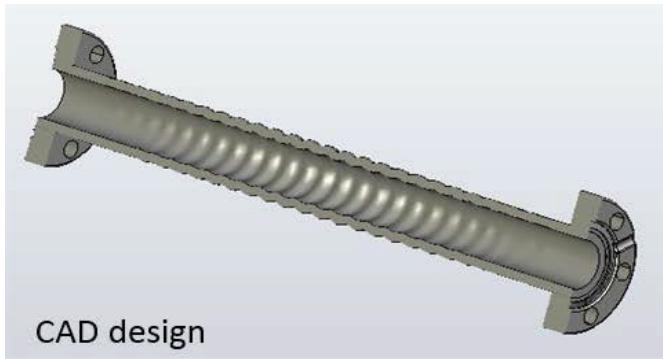
Elliptical TE_{11} tapered undulator.



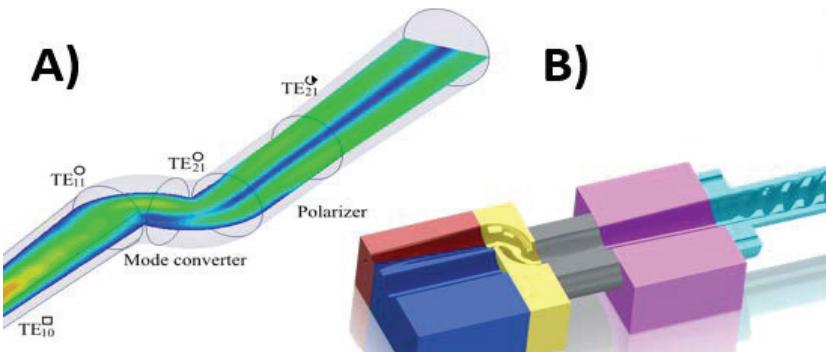
Reflection (S_{11}) measured. Working mode at just above 34 GHz.



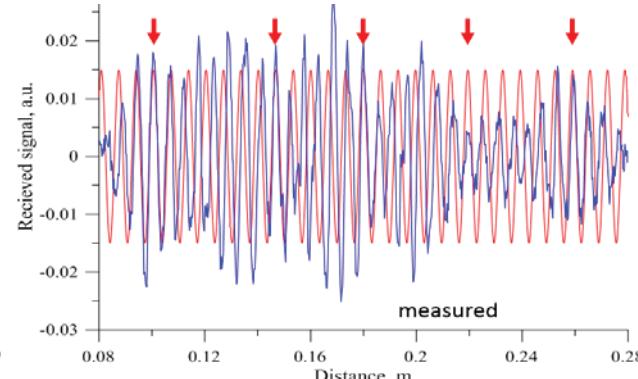
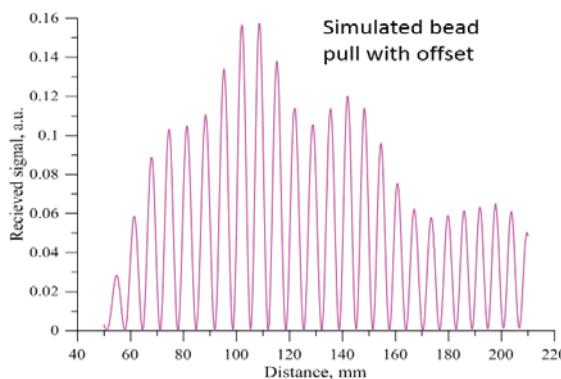
Strongly Tapered Helical RF Undulator



DMLS printed from Aluminum

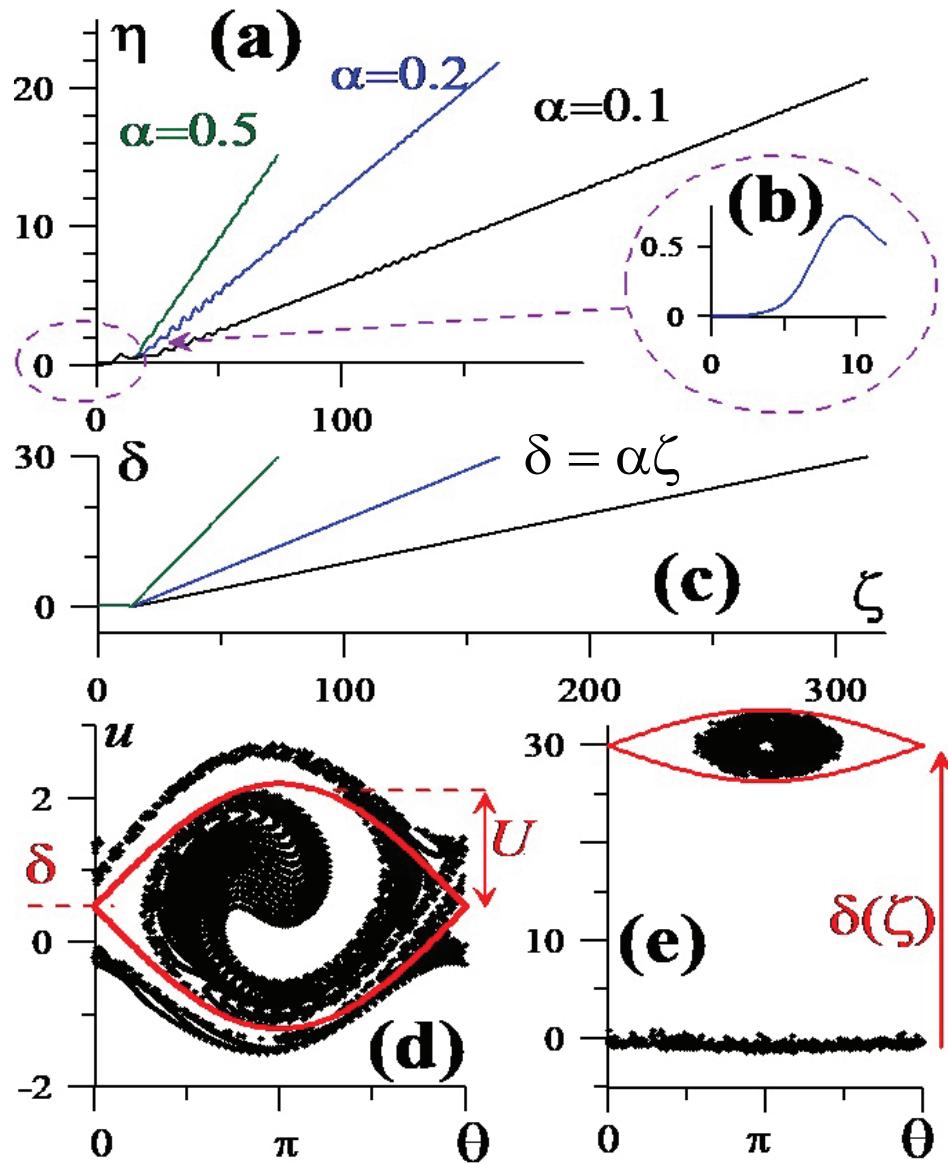


Cold test mode launcher from a standard rectangular waveguide TE_{10} mode into circularly polarized TE_{21} mode.



TE₁₁-TE₂₁-TM₁₁ undulator field balance. *Left: simulation with 0.5mm bead offset from centerline. Right: Bead pull measurement (blue) and constant period sine function (red).*

Simulation of Trapping Regime in Strongly Tapered Undulator



Regime of trapping in the case of a relatively small energy spread, $S=2$.

(a) and (c): normalized efficiency and mismatch versus the axial coordinate at three different rates α of the profiling of the mismatch.

(b) : evolution of the efficiency in the regular section.

(d) and (e): positions of the bucket and electrons on the phase plane at the end of the regular section (d) and at the end of the interaction (e), in the case of $\alpha=0.2$.

The normalized electron efficiency is related with the wave amplitude by the energy conservation law:

$$\eta = \langle u - u_0 \rangle = \frac{1}{2} [|a|^2 - |a_0|^2]$$

Equations and Calculation Model

$$\frac{du}{d\zeta} = \text{Ref}(\zeta) a \exp(i\theta) \quad \frac{d\theta}{d\zeta} = u - \delta(\zeta) \quad \frac{da}{d\zeta} = \langle f * \exp(-i\theta) \rangle$$

$u = (\gamma_0 - \gamma)/\gamma_0\rho$ - is electron energy change,

$\zeta = z/L_{gain}$ - is a normalized axial coordinate,

$\theta = \omega t - (2\pi/\lambda_u + k_{||})z$ - is a resonant electron phase with respect to the wave,

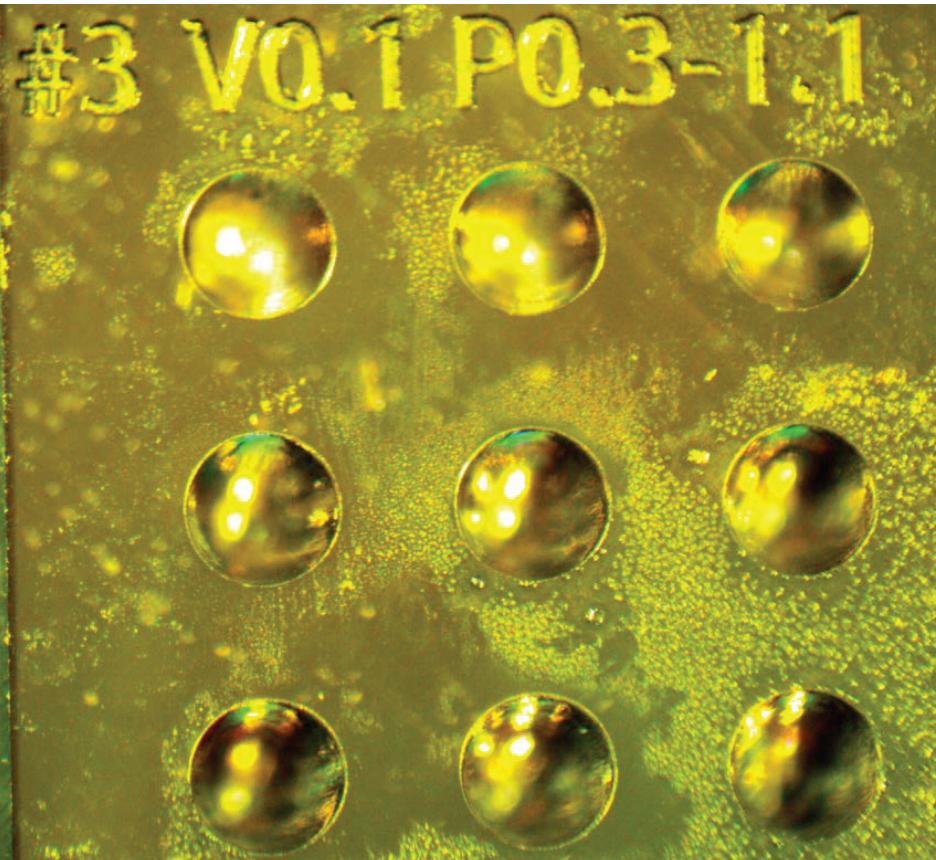
a - is a normalized wave amplitude, $a(0) = a_0$

$\delta = (\gamma_0 - \gamma_{res})/\gamma_0\rho$ - is a normalized mismatch of the electron-wave resonance,

$f(\zeta)$ - describes profiling of the system.

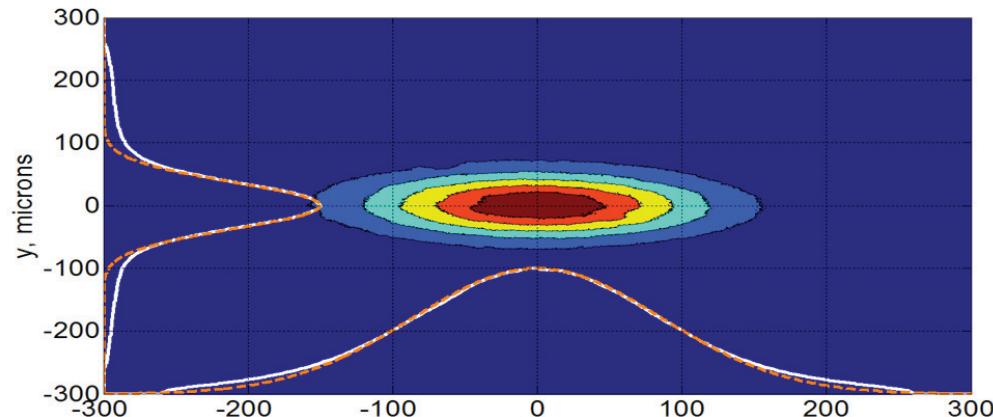
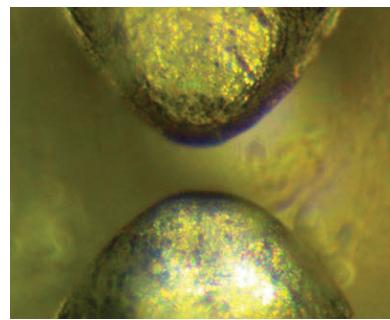
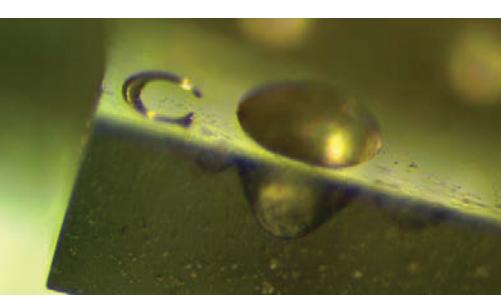
$u(0) = u_0 \in [-S/2, S/2]$, where S – is an amplitude of energy spread.

Diamond Refractive Lens

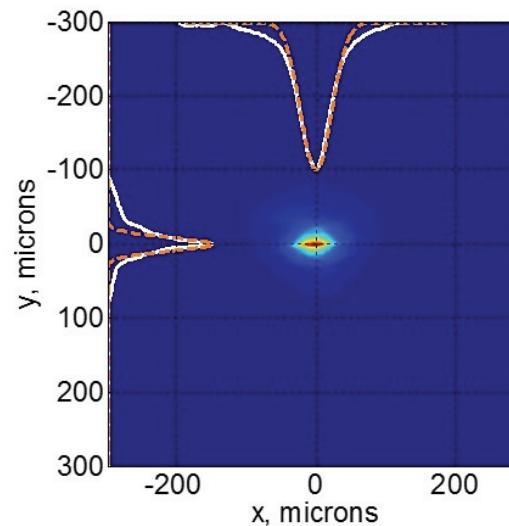
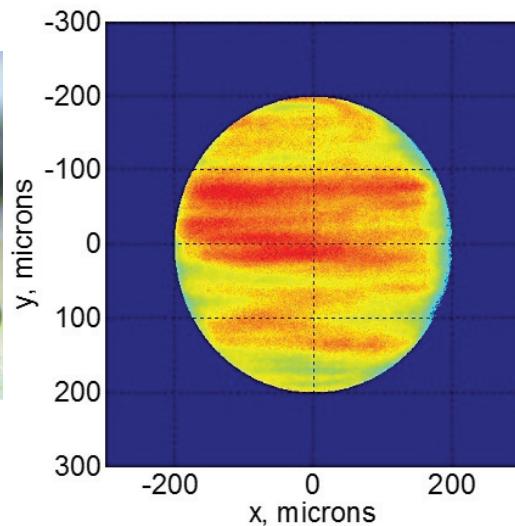
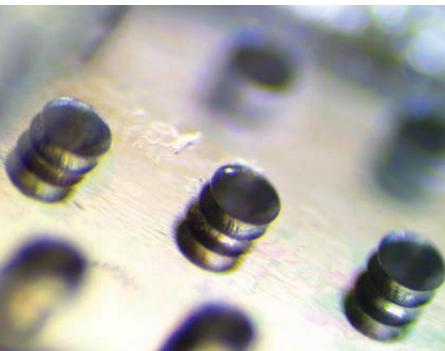


- Why?
 - High [peak/average] heat load / thermal stability
 - Single crystal possible vs polycrystalline beryllium
 - Radiation damage
- How?
 - fs-laser ablation of diamond
 - post-polishing

Diamond CRL



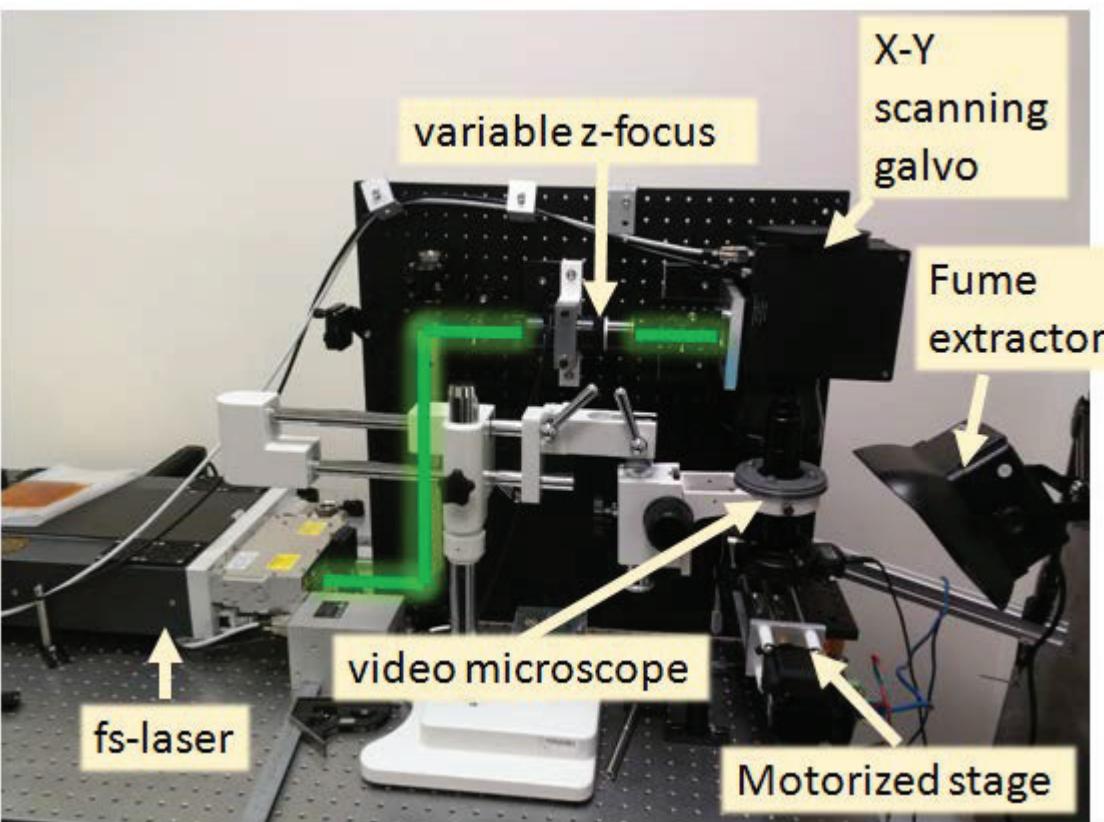
Source refocusing at IBMAPS (S. Stoupin)
Gain 5.71_{theory} vs 2.83_{exp}



CRL test at BIOCAT IIT (O. Antipova) - APS (S. Stoupin)

X-ray: **11.85 keV**
ID – Lens **62m**
R = 105 um
f = 3.36 m (3 lens)
Pinhole = **400 um**
Focused beam:
24.5 um x 17.6 um
Gain 50-100

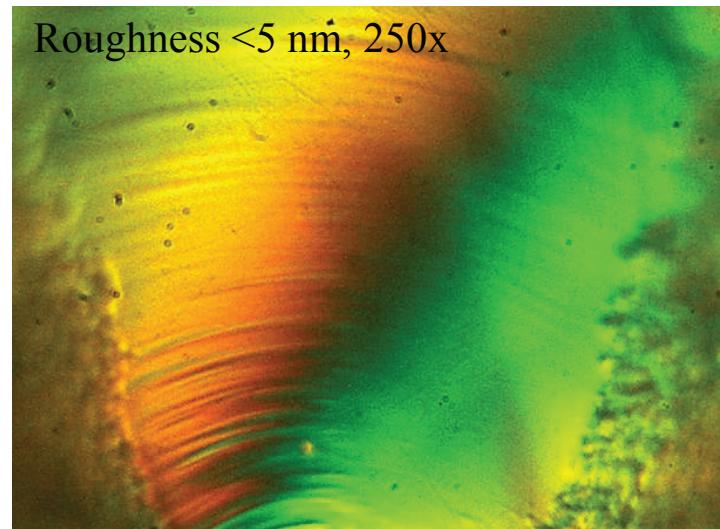
Femtosecond lens cutter and Polishing development@Euclid



As-ablated roughness is <1um
We post-polish to 5nm rms



Roughness <5 nm, 250x



Summary

- Preliminary calculations show that concept of the XFELO with self-modulated Q-factor is appealing:
 - It allows XFELO easy to start up;
 - The concept is also promising to provide high efficiency at steady state condition due to trapping regime.
- Tapered RF undulator and diamond CRL are under investigation at Euclid.

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